



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Reiki WATANABE

Serial No.: 10/743,314

Filed: December 23, 2003

For: PROCESSING EQUIPMENT AND PROCESSING METHOD

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)(1)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the examiner consider and cite of record the six (6) documents listed on the attached. Copies of the two Japanese language documents, published English language abstracts thereof, and a copy of the literature article by Tuomo Suntola are also submitted herewith.

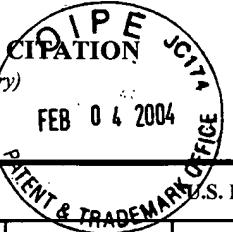
Respectfully submitted,

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Dated: February 4, 2004

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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) OKA-C387	Application Number 10/743,314		
				Applicant(s) Reiki WATANABE			
				Filing Date 12/23/03	Group Art Unit		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,879,459	3/9/99	GADGIT et al	118	715	
		6,174,377	1/16/01	DOERING et al	118	729	
		6,387,185	5/14/02	DOERING et al	118	729	
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	2002-4054	1/9/02	JP				
	2001-348666	12/18/01	JP				
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
		Handbook of Thin Film Process Technology, B1.5:1-B1.5.17, 1995 IOP Publishing Ltd.					
EXAMINER				DATE CONSIDERED			

EXAMINER:

22/24

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